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OCT 12 2003  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wen-Ming Chen Group Art Unit: 1763  
Serial No.: 10/081,665 Examiner: Kackar, Ram N.  
Filed: 02/21/2002 In Response to Office  
Action Dated: August 12, 2003

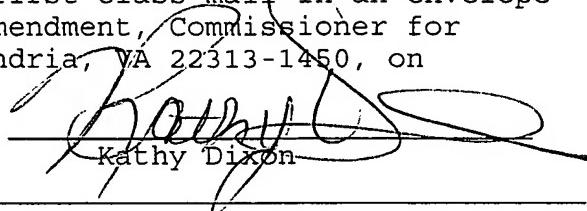
For: MICROCHIP FABRICATION CHAMBER WAFER DETECTION  
Attorney Docket No.: 67,200-662

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Date: 11/10/03

  
Kathy Dixon

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT/RESPONSE UNDER 37 C.F.R. §1.111

Dear Sir:

In response to the Office Action of August 12, 2003, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listings of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.